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| FORM HDP-1449 (Based on Form PTO-1449)<br><br><b>PATENT AND TRADEMARK OFFICE</b><br><b>INFORMATION DISCLOSURE CITATION</b><br>(Use several sheets if necessary)<br><br>Sheet 1 of 1 | ATTORNEY DOCKET NO. | SERIAL No. |
|   | 9319S-000648        | 10/783,979 |
|   | APPLICANT           |            |
|   | Shintaro ASUKE      |            |
|   | FILING DATE         | GROUP      |
|   | February 20, 2004   | 1731       |

| U.S. PATENT DOCUMENTS |                     |                 |         |               |                 |                              |
|-----------------------|---------------------|-----------------|---------|---------------|-----------------|------------------------------|
| Ref. Desig.           | Examiner's Initials | Document Number | Date    | Name          | Class/ Subclass | (If appropriate) Filing Date |
| 1.                    |                     | 5,571,325       | 11/1996 | Ueyama et al. |                 |                              |

| FOREIGN PATENT DOCUMENTS |                     |                 |           |         |                 |               |    |
|--------------------------|---------------------|-----------------|-----------|---------|-----------------|---------------|----|
| Ref. Desig.              | Examiner's Initials | Document Number | Date      | Country | Class/ Subclass | Translation * |    |
|                          |                     |                 |           |         |                 | Yes           | No |
| 1.                       |                     | 2000-164671     | 6/16/2000 | Japan   |                 | X             |    |
| 2.                       |                     | 2002-012319     | 1/15/2002 | Japan   |                 | X             |    |

| OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.) |                     |   |
|--|---------------------|---|
| Ref. Desig.  | Examiner's Initials |   |
| 1.   |                     | Communication from Chinese Patent Office regarding counterpart application (and English translation thereof). |

\*One or more of the English translation documents submitted herewith may be Abstracts only or partial machine created translations from the Japanese Patent Office. As such, the submitter does not necessarily vouch for their accuracy. Additional information may be obtained from the Japanese Patent Office web site at [www.jpo.go.jp](http://www.jpo.go.jp)

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| Examiner: | Date Considered: |
|-----------|------------------|

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